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Optics Communications

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Surface plasmon polariton excitation and manipulation by nanoparticle arrays

V. Coello a,*, S.I. Bozhevolnyi b

- ^a Unidad Monterrey CICESE. Alianza Sur 203. Autopista al Aeropuerto Km 10. PIIT CP 66600 Apodaca. NL. Mexico
- b Institute of Sensors, Signals and Electrotechnics (SENSE), University of Southern Denmark, Niels Bohrs Alle 1E, DK-5230 Odense M, Denmark

ARTICLE INFO

Article history: Received 19 December 2008 Received in revised form 24 March 2009 Accepted 8 April 2009

PACS: 73.20.Mf 71.36.+c 61.46.Df

Keywords:
Surface plasmons polaritons
Plasmonics
Nanoparticles
Green's function method

ABSTRACT

Using a vectorial dipolar model for multiple surface plasmon-polariton (SPP) scattering [T. Søndergaard, S.I. Bozhevolnyi, Phys. Rev. B 67 (2003) 165405], we investigate the possibility of simultaneous SPP excitation and in-plane manipulation with square-lattice arrays of nanoparticles. The SPP excitation followed by focusing and/or waveguiding of SPP waves is observed with nanoparticle arrays of different shapes, demonstrating the feasibility of the suggested approach.

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1. Introduction

In the last years there has been growing interest in the optical manipulation of surface plasmon-polaritons (SPPs) fields. SPPs are electromagnetic excitations coupled to electron plasma oscillations, which have the property of propagating along a metaldielectric interface as quasi two-dimensional interface waves [1]. SPPs open promising technological perspectives within nanooptics, e.g., for miniaturization of photonics circuits with length scales much smaller than currently achievable, inter-chip and intra-chip applications in computer systems, and bio/sensor-systems [2-4]. SPP micro-optical elements such as mirrors [5-7], band-gap [8] and localization [9] based waveguides, and various focusing structures [10,11] are only some examples of initial attempts to build plasmonic devices. For any plasmonic devices, one has to consider the issue of SPP excitation with free-propagating optical radiation. Traditional SPP excitations methods are based on the use of glass prims as couplers [1]. An alternative is the use of subwavelength hole arrays on a thick metal film as a mechanism for the SPP launching along metal surfaces [12,13]. Another method of SPP excitation consists of optically illuminating a nanostructure (ridge, particle) located at the top of an air/metal interface. Such SPP launching has been used for quantitative experimental analysis of a SPP interferometer [14], SPP focusing with nanoparabolic chains [15], and testing of refractive SPP nanostructures [16].

Considering the SPP interaction with and manipulation by arrays of surface scatterers [5–16], extensive theoretical studies have also been conducted. The theoretical framework, however, is not trivial, since even a relative simple case as the SPP scattering due to a single circular nanoparticle requires elaborated numerical simulations [17]. A relative simple scalar multiple scattering approach was used for simulation of SPP micro-components [18] and photonic band-gap structures [19] formed by a set of dipolar (nanosized) scatterers. Here, certain limitations on the accuracy of numerical results should be borne in mind [20]. For example, the effective polarizability of an individual scatterer is a phenomenological quantity that is difficult to relate to scatterer parameters such as size, susceptibility, etc. On the other hand, using the dipole scattering approach a theory for light scattering from a random array of nanoparticles, spaced much less than an optical wavelength, was developed [21]. In this work, the authors deal with the randomness in particle positions by convolving the single-particle Green's dyadic with a correlation function that describes the average properties of the particle distribution [21]. Furthermore, an approach based on the RLC circuit analogy was developed to produce analytical values for electromagnetic field enhancements within nanoarrays [22]. Lately, the scalar approach of Ref. [18] has been extended into a vectorial dipolar model for SPP multiple scattering [20,23] and used to calculate SPP scattering produced by band-gap

^{*} Corresponding author. Tel.: +528 183592587. E-mail address: vcoello@cicese.mx (V. Coello).

structures [20] and model the operation of a micro-optical SPP interferometer [24]. Recently, this model was further developed [25] and applied to the problem of SPP guiding by chains of strongly interacting nanoparticles [26]. The developed model is based on the Green's function formalism and the dipole approximation for field scattering by nanoparticles.

Here, using the vectorial dipolar model for multiple SPP scattering [20,23,25], we investigate the possibility of simultaneous SPP excitation and propagation control with periodic square arrays of nanoparticles illuminated by a normally incident Gaussian beam. SPP focusing and waveguiding are demonstrated with different (in shape) nanoarrays, exhibiting features that are closely resembled the experimental results for SPP scattering on nanostructures recently reported [15,16]. It should be noted that the light-SPP coupling efficiency in this configuration is expected to be similar to that of a rectangular ridge, since an array of nanoparticles in the limit of vanishingly small inter-particle distances should exhibit the scattering properties that are similar to those of a continuous rectangular ridge. Experimental and theoretical investigations of SPP excitation with individual ridges indicated that the overall excitation efficiency for 350-nm-wide and 130-nm-high gold ridges can reach 7% at the free-space wavelength of 800 nm [27]. For our configuration, the direct evaluation of the optimum SPP coupling efficiency using the vectorial dipolar model is cumbersome and typically omitted [28], since it should involve, among other things, a careful analysis of strong particle-surface interactions whose accurate description might require to go beyond the framework of dipole scattering approach [25].

We would like to emphasize that the main idea of the proposed approach is in avoiding the usage (in plasmonic circuits utilizing control of SPP propagation by surface nanostructures) of additional interfacing elements such as, for example, in-coupling ridges and focusing elements.

2. The model

The numerical model is based on the following. When light is incident on a metal/dielectric interface with scattering objects, the objects can be modelled as point-like dipoles. This assumption leads to the construction of an approximate Green's tensor describing the SPP scattering by such dipoles. The validity of the model is established for relatively large inter-particle distances ($>\lambda_0/2$) whereas for smaller distances one has to include multipolar contributions in the scattered field [20]. Thus, the polarization of the ith scatterer takes the form:

$$P_i = \alpha \cdot E_0(r_i) + \frac{k_0^2}{\varepsilon_0} \sum \alpha \cdot G(r_i, r_n) \cdot P_n, \tag{1}$$

where α is the polarizability of the scatterers, $E_0(r_i)$ is the incident field at the site of scatterer i, k_0 is the wave vector of the incoming field in the space, $G(r_i, r_n)$ the Green tensor for SPP to SPP scattering (total field propagator) [20]. The Green tensor is the sum of a direct contribution, G^d , in this case the free space Green's tensor, and an indirect contribution, G^S , that describes both reflection from the metal/dielectric interface and excitation of SPPs. Here the polarizability α has the surface dressing included i.e. the coupling of the dipole to itself through reflection in the surface. Furthermore, the polarizability, α , is a tensor, describing the polarizability effect in each direction [20]:

$$\alpha = \left(I - k_0^2 \frac{\alpha_0}{\varepsilon_0} \cdot G^{S}(r, r')\right)^{-1} \cdot \alpha^0.$$
 (2)

Where α_0 is the free space polarizability tensor given as

$$\alpha^0 = \varepsilon_0 I 4\pi a^3 \frac{\varepsilon_2 - 1}{\varepsilon_2 + 2},\tag{3}$$

with I being the unit dyadic tensor. Eq. (2) is valid when the long-wavelength electrostatic approximation has been used. Such approximation assumes that the field is constant within the considered range, which corresponds to the size of the scatterer. For the approximation to be valid, the wavelength must be much bigger than the size of the scatterer. If the image dipole approximation is used on $G^S(r, r')$ in Eq. (2) the following result is obtained for the polarizability tensor of Eq. (1).

$$\alpha \approx \left[\frac{\epsilon_2 - 1}{\epsilon_2 + 1} \cdot \frac{\epsilon_2 - 1}{\epsilon_2 + 2} \left(\frac{1}{8} \hat{x} \hat{x} + \frac{1}{8} \hat{y} \hat{y} + \frac{1}{4} \hat{z} \hat{z} \right)\right]^{-1} \cdot \alpha^0. \tag{4}$$

It should be mentioned that the dipole approximation assumes that the phase delay of the field, when it moves over the scatterer, is negligible. Mathematically this means $e^{kr} \cong 1$ for a given field. This means again that the size of the scatterer should be smaller than the wavelength, which is the main assumption in the model. When Eq. (4) has been used in Eq. (1) to determine the polarization, the final step is to calculate the field outside the scatterer as a selfconsistent field:

$$E(r) = E^{0}(r) + \frac{k_0^2}{\varepsilon_0} \sum_{r} G(r, r') \cdot P_n. \tag{5}$$

The complete analysis and validity of the model is beyond the scope of this report and can be found elsewhere [20].

3. Numerical results

Following a step-by-step process, first we calculate the in-plane scattered field created by a normally incident Gaussian beam $(\lambda_0 = 750 \text{ nm}, \text{ FWHM} = 5 \mu\text{m}, x\text{-pol}) \text{ of unit amplitude impinging}$ on a 150-nm-period square lattice (width $w \approx 1.05 \,\mu\text{m}$, length $L \approx 15 \,\mu\text{m}$) of nanoparticles with radius, r, of 20 nm (Fig. 1a and b). The entire system is simulated on a gold surface with dielectric constant $\varepsilon = -23.11 + 1.4i$. The configuration and the illumination conditions, in general, can be considered as fairly similar to experimental realized ones [15,16], for example, the wavelength of 750 nm can be experimentally obtained by using a wavelengthtunable (700-860 nm) Ti:sapphire laser. Fig. 1b shows numerical simulations of a direct SPP excitation taking place at the lower (along y-axis) nanoarray edge. Hereafter, for all images, the total field is calculated 80 nm above the air-gold interface, and the incident beam has been removed; i.e; only scattered SPP appear in the pictures. Fig. 1c shows the power of the SPP beam propagating in the positive direction of y-axis calculated as a function of the incident beam position (along the y-axis). The calculations were made for two distinct w values. An asymmetric behavior was exhibited in both calculated curves. One can notice that once the incident beam is not in contact with the nanoarray, the optical power is weak (Fig. 1c); this is expected, considering that no SPP can be launched without interacting with the nanoarray. Once the launching of SPP is achieved, in this way, from an application point of view, one can exploit the nanoarrays in order to manipulate the SPP propagation.

A nanodevice, realizable by a certain array structure, is a focusing micromirror. The concept is to place nanoparticles along a parabolic chain $(y-y_0)^2 = 4F(x-x_0)$ where the coordinate (x_0,y_0) is located at the bottom of the mirror which coincides with the incident beam position, the *y*-axis is oriented along the optical axis and *F* is the focal length. (Fig. 2a and b). A nanodevice, realizable by a certain array structure, is a focusing micromirror. The concept is to place nanoparticles along a parabolic chain $(y-y_0) = 4F(x-x_0)^2$ where the coordinate (x_0,y_0) is located at the bottom of the mirror which coincides with the incident beam position, the *y*-axis is ori-

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